

PATENT
Atty. Dkt No. AMAT/5951/CMP/ECP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:
Zheng

Serial No.: 09/981,508

Confirmation No.: 6901

Filed: October 16, 2001

For: IMPROVED ECP GAP FILL BY
MODULATING THE VOLTAGE ON
THE SEED LAYER TO INCREASE
CUT CONCENTRATION INSIDE
FEATURE

Group Art Unit: 1742

Examiner: Nicolas, Wesley A.

MAIL STOP
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8I hereby certify that this correspondence and the documents
referred to as attached therein are being facsimile transmitted to
the U.S. Patent and Trademark Office to the fax number
indicated by the Examiner, namely, fax number 703-872-9306
to the attention of the named Examiner, on the date below.

Date

Signature

AMENDMENT AFTER ALLOWANCE
UNDER 37 CFR §1.312

Applicants request entry and consideration of the following amendment made
after the mailing of the Notice of Allowance.

IN THE SPECIFICATION:

Please amend the title of the application to read as follows:

"IMPROVED ECP GAP FILL BY MODULATING THE VOLTATE ON THE SEED LAYER
TO INCREASE COPPER CONCENTRATION INSIDE FEATURE"

A marked up copy of the amendment is attached.